

Case No. 02GR102454481

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

In re Application of: **GRIS**
Serial No.: **Not yet assigned**
Filed: **Herewith**
For: **PROCESS AND INSTALLATION FOR DOPING AN ETCHED
PATTERN OF RESISTIVE ELEMENTS**
Sir:

Transmitted herewith is an INFORMATION DISCLOSURE STATEMENT in the
above-identified application.

1. ☒ This IDS is submitted under 37 C.F.R. § 1.97. No fee is required.
2. ☐ This IDS is submitted under 37 C.F.R. § 1.97(c). Enclosed is a check in the
amount of \$ 180.00.
3. ☐ This IDS is submitted under 37 C.F.R. § 1.97(c) and (e). No fee is required.
4. ☐ This IDS is submitted under 37 C.F.R. § 1.97(d) and (e). Enclosed is a check
in the amount of \$ 130.00 to cover the petition fee.
5. ☒ The Commissioner is hereby authorized to charge or credit any discrepancies
in fee amounts to Deposit Account No. 01-0484.
6. ☒ Please associate this application with Customer No. 27975.



27975

PATENT TRADEMARK OFFICE

Date: October 20, 2003


MICHAEL W. TAYLOR
Reg. No. 43,182

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Patent Application of:
GRIS

Serial No. **Not yet assigned**

Filing Date: **Herewith**

For: **PROCESS AND INSTALLATION FOR
DOPING AN ETCHED PATTERN OF
RESISTIVE ELEMENTS**

)
) I HEREBY CERTIFY THIS PAPER OR FEE IS BEING
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) ALEXANDRIA, VA 22313-1450.

) EXPRESS MAIL NO: EV301516125US

) DATE OF DEPOSIT: October 20, 2003

) NAME: Justin Goree

) SIGNATURE: Justin Goree

CITATION UNDER 37 CFR §1.97

COMMISSIONER FOR PATENTS
P.O. BOX 1450
ALEXANDRIA, VA 22313-1450

Sir:

Attached is Form PTO-1449 listing several references for consideration in the examination of the above-identified application. A copy of each reference is also enclosed. It is requested that these references be considered by the Examiner and officially made of record in accordance with the provisions of 37 CFR §1.97 and Section 609 of the MPEP.

Respectfully submitted,

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INFORMATION DISCLOSURE STATEMENT			Atty Docket: Serial No.: Applicant: Filing Date: Group:		02GR102454481 Not Yet Assigned Gris Herewith		
U.S. PATENT DOCUMENTS							
Examiner Initials		Document Number	Date	Name	Class	Sub Class	Filing Date
	AA	6,358,809	3/19/02	Nobinger et al.	438	382	
	AB						
	AC						
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
FOREIGN PATENT DOCUMENTS							
		Document Number	Date	Country	Class	Sub Class	Translation
	AN	0167851	1/15/86	EP	H01L21	66	
	AO						
	AP						
	AQ						
OTHER ART (Including Author, Title, Date, Pertinent Pages, etc.)							
	AR	Patent Abstracts of Japan, Vol. 017, No. 475 (C-1103), August 30, 1993 & JP 05117088A (Sumitomo Electric Ind. Ltd.), May 14, 1993					
	AS	Hutchings, Localized Semiconductor Diffusions Utilizing Local Laser Melting in Doping Atmospheres, January 1974, IBM Technical Disclosure Bulletin, Vol. 16, No. 8, January 1, 1974, Pages 2585-2586, XP002246185					
	AT						
EXAMINER:				DATE CONSIDERED:			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.